

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. HIROI, et al  
Serial No.: 10/062,666  
Filed: February 5, 2002  
For: PATTERN INSPECTION METHOD AND  
SYSTEM THEREFOR  
Group: 2881  
Examiner: J. Berman  
Conf. No.: 4688

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop: Amendment (Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 30, 2009

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated April 30, 2009, and in light of the telephone discussion with the Examiner of September 24, 2009. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.